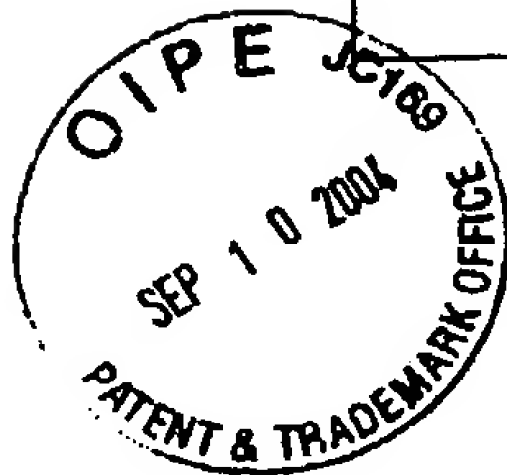


I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: September 7, 2004

Signature:

*Scott E. Baxendale*  
(Scott E. Baxendale)



Reply Under 37 C.F.R. § 1.116  
Expedited Procedure  
Art Unit: 3712

Docket No.: 19036/37209  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yasuhiro Koizumi, et al

Application No.: 09/812,668

Group Art Unit: 1763

Filed: March 20, 2001

Examiner: Parviz Hassanzadeh

For: ION PLATING DEVICE AND ION PLATING  
METHOD

*DO NOT ENTER*

**AMENDMENT AFTER FINAL REJECTION PURSUANT TO 37 C.F.R. § 1.116**

*p.l.  
9-16-04*

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This amendment is being submitted in response to the Office action dated May 5, 2004. Applicants hereby request a one-month extension of time to respond to the Office action. This response is therefore timely filed within the extended period of response as the expiration for taking action (weekend of September 4-6, 2004) were days in which the Patent Office was closed (Saturday/Sunday/Monday Labor Day Holiday), and the present response is being forwarded to the Patent Office on September 7, 2004, the next day in which the United States Patent and Trademark Office is open for business. This amendment is accompanied by a Petition for a One-Month Extension of Time and a check in the amount of \$110.00 for the requisite petition fee. Applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

Please amend the above-identified application as follows: